



PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Shoji MIYAKE et al.

Application No.: 10/539,254

Docket No.: 123612

Filed: June 16, 2005

For: PLASMA GENERATOR, PLASMA CONTROL METHOD AND METHOD OF
PRODUCING SUBSTRATE

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REQUEST FOR CORRECTION OF PALM RECORDS

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TC 1700

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,


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Date: November 22, 2005

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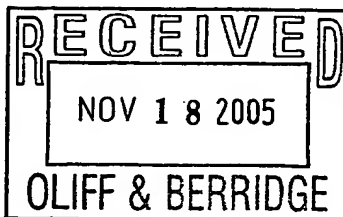
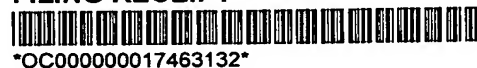
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/539,254	06/16/2005	1763	1750	123612	15	37	2

25944
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**CONFIRMATION NO. 2416****FILING RECEIPT**

OC000000017463132

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TC 1700**Assignment For Published Patent Application**

Japan Science and Technology Agency, Kawaguchi-shi, JAPAN
Shoji Miyake, Suita-shi, JAPAN
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Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/16007 12/12/2003

Foreign Applications

JAPAN 2002-363988 12/16/2002
JAPAN 2002-363989 12/16/2002
JAPAN 2003-14718 01/23/2003

Projected Publication Date: 02/23/2006

Non-Publication Request: No

Next page →

Early Publication Request: No

Title

Preliminary Class

118

~~Plasma generation device, plasma control method, and substrate manufacturing method~~
Plasma Generator, Plasma Control Method and Method of Producing Substrate

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